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03/06/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10092456	FILING DATE 03/06/2002	CLASS 255	SUBCLASS	GAU 2818	EXAMINER
<b>**APPLICANTS:</b> Hwang Jeng; Jin Guangxiang; Chen Xiaoyi;					
<b>**CONTINUING DATA VERIFIED:</b>					
<b>**FOREIGN APPLICATIONS VERIFIED:</b>					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiner's initials				ATTORNEY DOCKET NO AMAT/6437/ETCH/METAL/JB	
TITLE : Etching methods for a magnetic memory cell stack					

U.S. DEPT. OF COMMERCE PAT & TRADEMARK OFFICE (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
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